

# Searching PAJ

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## Search Results : 5

Index Indication

Clear

**Text Search**

If you want to conduct a Number Search, please click on  
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**Number Search**

### Applicant,Title of invention,Abstract — e.g. computer semiconductor

If you use the AND/OR operation, please leave a SPACE between keywords.

One letter word or Stopwords are not searchable.

piezoelectric

AND

AND

cantilever

AND

AND

pedestal

AND

AND

### Date of publication of application — e.g.19980401 - 19980405

-

AND

### IPC — e.g. D01B7/04 A01C11/02

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# Searching PAJ

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**Number Search****Applicant,Title of invention,Abstract — e.g. computer semiconductor**

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One letter word or Stopwords are not searchable.

 piezoelectric crystal**AND****AND** cantilever**AND****AND****AND****AND****Date of publication of application — e.g.19980401 - 19980405** - **AND****IPC — e.g. D01B7/04 A01C11/02**

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AND

 

AND

 

AND

**Date of publication of application — e.g. 19980401 - 19980405** - 

AND

**IPC — e.g. D01B7/04 A01C11/02**

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**Number Search****Applicant,Title of invention,Abstract — e.g. computer semiconductor**

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One letter word or **Stopwords** are not searchable.

piezoelectric

AND

AND

cantilever

AND

AND

ridge

AND

AND

**Date of publication of application — e.g. 19980401 - 19980405**

-

AND

**IPC — e.g. D01B7/04 A01C11/02**

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**Number Search****Applicant,Title of invention,Abstract — e.g. computer semiconductor**

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One letter word or **Stopwords** are not searchable.

piezoelectric

AND

AND

cantilever

AND

AND

mesa

AND

AND

**Date of publication of application — e.g.19980401 - 19980405**

-

AND

**IPC — e.g. D01B7/04 A01C11/02**

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## Canadian Patents Database

### Search Results

05/24/2005 - 16:06:33

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Query :

( ( piezoelectric <and> cantilever <ar

Query: ( ( piezoelectric <and> cantilever <and> (ridge <or> pedestal)) )  
<in> claims )

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Last Modified: 2002-12-31



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Any Text Field:

resonator <or> oscillator

Title:

cantilever <and> conductive <ne>

Abstract:

Claims:

Inventor:

Inventor Country:

Inventor Country Not Selected



Owner:

Applicant:

IPC:

CPC:

PCT Filing Number:

Intl Publication Number:

Only with License Available:

**WITHIN**

All documents  PCT  Non-PCT

**AND**

In both languages |

For documents only issued on or after  
Aug. 15, 1978

English  French

**AND**

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Results per lists

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Last Modified: 2004-01-08



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[Search Summary]**Results of searching in PCT (Full Text) for:****piezoelectric and cantilever and (ridge or pedestal): 87 records***Showing records 1 to 25 of 87 :*[Next 25 records](#)[Start At](#)[Refine Search](#)

piezoelectric and cantilever and (ridge or pedestal)

**Title**

1. [\*\*\(WO 2005/043159\) WATER-SOLUBLE COMPOUND\*\*](#)
2. [\*\*\(WO 2005/031165\) MICRO-PUMP\*\*](#)
3. [\*\*\(WO 2005/022606\) THERMOACOUSTIC PIEZOELECTRIC GENERATOR\*\*](#)
4. [\*\*\(WO 2005/017937\) SENSOR ARRAY FOR MEASURING PLASMA CHARACTERISTICS IN PLASMA PROCESSING ENVIRONMENTS\*\*](#)
5. [\*\*\(WO 2005/010125\) DRUM PEDAL STABILIZER\*\*](#)
6. [\*\*\(WO 2005/001903\) PULSE DRIVE OF RESONANT MEMS DEVICES\*\*](#)
7. [\*\*\(WO 2004/113895\) HIGH THROUGHPUT MICROCANTILEVER DETECTOR\*\*](#)
8. [\*\*\(WO 2004/099826\) POLISHED POLYIMIDE SUBSTRATE\*\*](#)
9. [\*\*\(WO 2004/095593\) LED LIGHT ASSEMBLY WITH ACTIVE COOLING\*\*](#)
10. [\*\*\(WO 2004/052075\) IMPROVED EFFICIENCY AUDIBLE ALARM\*\*](#)
11. [\*\*\(WO 2004/052046\) THIN MEMBRANE TRANSDUCER\*\*](#)
12. [\*\*\(WO 2004/044552\) METHODS AND APPARATUS FOR INK DELIVERY TO NANOLITHOGRAPHIC PROBE SYSTEMS\*\*](#)
13. [\*\*\(WO 2002/051549\) HIGH SPEED LIQUID DEPOSITION APPARATUS FOR MICROARRAY FABRICATION\*\*](#)  
[Repub: 13.05.2004]
14. [\*\*\(WO 2004/029625\) DETECTING MOLECULAR BINDING BY MONITORING FEEDBACK CONTROLLED CANTILEVER DEFLECTIONS\*\*](#)
15. [\*\*\(WO 2004/003384\) PIEZOELECTRIC MICROPUMP WITH DIAPHRAGM AND VALVES\*\*](#)
16. [\*\*\(WO 03/093165\) THERMAL MICRO-ACTUATOR BASED ON SELECTIVE ELECTRICAL EXCITATION\*\*](#)
17. [\*\*\(WO 03/081195\) PRESSURE MONITOR INCORPORATING SAW DEVICE\*\*](#)
18. [\*\*\(WO 03/066515\) MICROENGINEERED ELECTRICAL CONNECTORS\*\*](#)
19. [\*\*\(WO 03/062742\) SCANNING PROBE FOR DATA STORAGE AND MICROSCOPY\*\*](#)
20. [\*\*\(WO 03/050852\) COMPLEX MICRODEVICES AND APPARATUS AND METHODS FOR FABRICATING SUCH DEVICES\*\*](#)
21. [\*\*\(WO 03/046144\) MICROSCALE IMMOBILIZATION OF MOLECULES USING A HYDROGEL AND METHODS OF USE THEREOF\*\*](#)
22. [\*\*\(WO 03/043051\) MEASUREMENT DEVICE FOR ELECTRON MICROSCOPE\*\*](#)
23. [\*\*\(WO 03/038919\) PIEZOELECTRIC DEVICES\*\*](#)
24. [\*\*\(WO 02/025630\) MICROFABRICATED ULTRASOUND ARRAY FOR USE AS RESONANT SENSORS\*\*](#)  
[Repub: 03.04.2003]

Searching PCT (Full Text)...

[Search Summary]

Results of searching in PCT (Full Text) for:

**piezoelectric and cantilever and ( conductive or conducting ) near ( resin or adhesive )**: 0 records

[Refine Search](#)

piezoelectric and cantilever and (conductiv or condu

No records matching your query found in PCT (Full Text)

### Search Summary

**piezoelectric NEAR resin**: 16 occurrences in 11 records.

**cantilever NEAR resin**: 2 occurrences in 1 record.

(piezoelectric NEAR resin AND cantilever NEAR resin): 0 records.

**conductive NEAR resin**: 5051 occurrences in 660 records.

**conducting NEAR resin**: 304 occurrences in 99 records.

(conductive NEAR resin OR conducting NEAR resin): 749 records.

((piezoelectric NEAR resin AND cantilever NEAR resin) AND (conductive NEAR resin OR conducting NEAR resin)): 0 records.

**piezoelectric NEAR adhesive**: 79 occurrences in 35 records.

**cantilever NEAR adhesive**: 14 occurrences in 12 records.

(piezoelectric NEAR adhesive AND cantilever NEAR adhesive): 0 records.

**conductive NEAR adhesive**: 10316 occurrences in 2158 records.

**conducting NEAR adhesive**: 575 occurrences in 265 records.

(conductive NEAR adhesive OR conducting NEAR adhesive): 2312 records.

((piezoelectric NEAR adhesive AND cantilever NEAR adhesive) AND (conductive NEAR adhesive OR conducting NEAR adhesive)): 0 records.

(((piezoelectric NEAR resin AND cantilever NEAR resin) AND (conductive NEAR resin OR conducting NEAR resin)) OR ((piezoelectric NEAR adhesive AND cantilever NEAR adhesive) AND (conductive NEAR adhesive OR conducting NEAR adhesive))): 0 records.

Search Time: 4.34 seconds.



## **RESULT LIST**

63 results found in the Worldwide database for:  
**resonator or oscillator** in the title AND **cantilever** in the title or abstract  
(Results are sorted by date of upload in database)

- 1 SENSOR WITH CANTILEVER AND OPTICAL RESONATOR**  
Inventor: FREDERIX PATRICK LOUIS THEODOR; HUG  
HANS JOSEF  
EC:  
Publication info: AU2002321721 - 2004-03-03  
Applicant: UNI BASEL  
IPC: G12B21/08; G12B21/20; (+3)

**2 Vacuum-cavity MEMS resonator**  
Inventor: MA QING (US); CHENG PENG (US); (+1)  
EC: H03H3/007M; H03H9/10M; (+4)  
Publication info: US2005036269 - 2005-02-17  
Applicant: INTEL CORP (US)  
IPC: H01G4/00

**3 Method and apparatus for characterizing materials by using a mechanical resonator**  
Inventor: MATSIEV LEONID (US); BENNETT JAMES (US); (+1)  
EC: G01H13/00; G01N9/00B; (+10)  
Publication info: US2004074303 - 2004-04-22  
Applicant: SYMYX TECHNOLOGIES INC (US)  
IPC: G01H13/00; G01H3/04

**4 Method and apparatus for characterizing materials by using a mechanical resonator**  
Inventor: MATSIEV LEONID (US); BENNETT JAMES (US); (+1)  
EC: G01H13/00; G01N9/00B; (+10)  
Publication info: US2004074302 - 2004-04-22  
Applicant: SYMYX TECHNOLOGIES INC (US)  
IPC: G01H3/04

**5 Fabry-perot resonator and system for measuring and calibrating displacement of a cantilever tip using the same in atomic force microscope**  
Inventor: KIM JAE WAN (KR); EOM TAE BONG (KR)  
EC:  
Publication info: US2003226955 - 2003-12-11  
Applicant:  
IPC: H01J40/14

**6 HOLDING STRUCTURE OF PIEZOELECTRIC VIBRATION ELEMENT IN PIEZOELECTRIC DEVICE, PIEZOELECTRIC VIBRATOR, PIEZOELECTRIC OSCILLATOR, INSULATING PACKAGE, AND PIEZOELECTRIC VIBRATION ELEMENT**  
Inventor: KOMINE KENJI; HANZAWA MASANORI  
EC:  
Publication info: JP2004222006 - 2004-08-05  
Applicant: TOYO COMMUNICATION EQUIP  
IPC: H03H9/02; H03H9/05; (+2)

**7 SUPPORTING STRUCTURE FOR SAW RESONATOR AND OSCILLATOR USING THE SAME**  
Inventor: EGUCHI OSAMU  
EC:  
Publication info: JP2003298388 - 2003-10-17  
Applicant: KINSEKI LTD  
IPC: H03H9/25

**8 PIEZOELECTRIC OSCILLATOR AND MANUFACTURING METHOD THEREFOR**  
Inventor: ENDO HIDEO  
EC:  
Publication info: JP2002359536 - 2002-12-13  
Applicant: SEIKO EPSON CORP  
IPC: H03H9/09; H03H3/04; (+1)

**9 PIEZOELECTRIC OSCILLATOR**  
Inventor: KOBAYASHI HIROKAZU  
EC:  
Publication info: JP2002359536 - 2002-12-13  
Applicant: KINSEKI LTD  
IPC: H03H9/10; H03H9/02

**RESULT LIST**

7 results found in the Worldwide database for:  
**resonator cantilever pedestal** in the title or abstract  
(Results are sorted by date of upload in database)

**1 PIEZO-OSCILLATOR**

Inventor: SAITO HIROAKI; ISHITA AKINORI  
EC:  
Publication info: **JP2000134058** - 2000-05-12

Applicant: TOYO COMMUNICATION EQUIP  
IPC: H03H9/02; H03B5/32

**2 ALPO4 RESONATOR**

Inventor: KAWASHIMA HIROFUMI  
EC:  
Publication info: **JP61073047** - 1986-04-15

Applicant: SEIKO ELECTRONIC COMPONENTS  
IPC: G01L21/22; H03H9/21

**3 CRYSTAL RESONATOR**

Inventor: KAWASHIMA HIROFUMI  
EC:  
Publication info: **JP61073046** - 1986-04-15

Applicant: SEIKO ELECTRONIC COMPONENTS  
IPC: G01L21/22; H03H9/215

**4 LITHIUM TANTALATE RESONATOR**

Inventor: KAWASHIMA HIROFUMI  
EC:  
Publication info: **JP61073045** - 1986-04-15

Applicant: SEIKO ELECTRONIC COMPONENTS  
IPC: G01L21/22; H03H9/21

**5 LITHIUM NIOBATE RESONATOR**

Inventor: KAWASHIMA HIROFUMI  
EC:  
Publication info: **JP61073044** - 1986-04-15

Applicant: SEIKO ELECTRONIC COMPONENTS  
IPC: G01L21/22; H03H9/21

**6 LITHIUM NIOBATE RESONATOR**

Inventor: KAWASHIMA HIROFUMI  
EC:  
Publication info: **JP61057827** - 1986-03-24

Applicant: SEIKO ELECTRONIC COMPONENTS  
IPC: G01L21/22; H03H9/19

**7 OSCILLATOR**

Inventor:  
EC: H03H9/10; H03H9/21; (+1)  
Publication info: **GB1465970** - 1977-03-02

Applicant: SEIKO INSTR & ELECTRONICS  
IPC: H03H9/10; H03H9/20

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	Type	L #	Hits	Search Text	DBs
1	BRS	L1	4	"1465970"	EPO; DERWENT
2	IS&R	L2	6	("1465970").PN.	USPAT; USOCR; EPO; JPO; DERWENT
3	BRS	L3	56	piezoelectric same cantilever and pedestal	US- PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TD B
4	BRS	L4	79	piezoelectric same cantilever and ridge	US- PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TD B
5	BRS	L5	0	terayama-tosho.in.	USPAT
6	BRS	L6	4	terayama-toshio.in.	USPAT
7	BRS	L7	1	terayama-toshio.in.	USOCR